



DOCKET NO: VSEA 44-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul S. Buccos  
Serial No: 10/761,768  
Confirmation No: 2891  
Filed: January 21, 2004  
For: ION IMPLANTER SYSTEM, METHOD AND PROGRAM  
PRODUCT INCLUDING PARTICLE DETECTION  
Examiner: Kiet Tuan Nguyen  
Art Unit: 2881

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 24<sup>th</sup> day of November, 2004.

  
Cheryl Purcell

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

Transmitted herewith are the following documents:

- ☒ Response to Restriction Requirement
- ☒ Petition for One Month Extension of Time
- ☒ Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,  
**Paul S. Buccos, Applicant**

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